IFW S

APR. 0 5 2007 WE

Attorney Docket No. 09459.0001-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Toshihisa NOZAWA et al.

Examiner: Dhingra, R.

Application No.: 10/787,204

Group Art Unit: 1763

Filed: February 27, 2004

Confirmation No.: 4678

For:

SUBSTRATE PROCESSING

APPARATUS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants petition for a one month extension of time to file a reply to the Office Action mailed December 6, 2006. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter the attached reply and charge any additional required fees to Deposit Account 06-0916.

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: April 5, 2007

By: /David W. Hill/

David W. Hill

Reg. No. 28,220

04/06/2007 HMARZII 00000127 10787204 01 FC:1251 120.00 OP